

2829-

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of )  
MAEDA et al ) Art Unit: 2829  
Serial No.: 09/808,016 ) Examiner: Kilday  
Filed: March 15, 2001 )  
For: FILM-FORMING SURFACE )  
REFORMING METHOD AND )  
SEMICONDUCTOR DEVICE )  
MANUFACTURING METHOD )

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(C)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record Japanese Kokai 11-111714 a copy of which is submitted herewith along with a published English language abstract thereof.

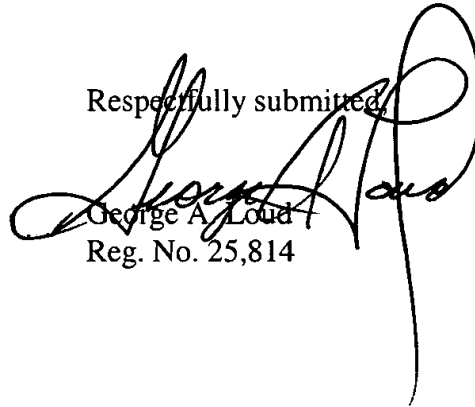
Also submitted herewith is a copy of an office action received in connection with Korean Patent Application 10-2001-0016176 by which Japanese Kokai 11-111714 was brought to applicants' attention. The examiner will note that the date of the Korean office action is May 27, 2003. The aforementioned Korean Patent Application 10-2001-0016176 is believed to correspond to the captioned application.

The second reference cited in the Korean Office Action of May 7, 2003, i.e., Korean Patent Publication 1995-7032 is believed to correspond to U.S. Patent 5,656,337 which is already of record.

CERTIFICATION

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



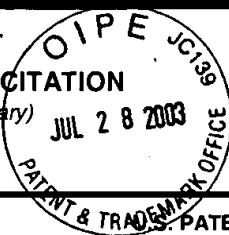
George A. Loud  
Reg. No. 25,814

Dated: July 28, 2003

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(Use several sheets if necessary)



**OKA-C062**

**09/808,016**

MAEDA et al

FILING

15 MAR 2001

GROUP

## PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

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**EXAMINER**

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.